

**RECEIVED  
CENTRAL FAX CENTER**

NOV 29 2006

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
(Attorney Docket No. 100176)**

First Inventor: Roland K. Sevilla  
Serial No.: 10/601,601  
Filing Date: 06/23/2003  
Title: POLISHING PAD FOR  
ELECTROCHEMICAL-  
MECHANICAL POLISHING  
Examiner: Maurina T. Rachuba  
Art Unit: 3723

**Certificate of Facsimile Transmission**

I, Mariejose Monsalvo, hereby certify that this paper and enclosure(s), if any, are hereby being transmitted by facsimile to the US Patent and Trademark Office's central fax No. (571) 273-8300 on 29 NOV 06.

  
(Sender's signature)

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO Office Action**

This is a reply to the Office Communication mailed November 1, 2006 for the above captioned U.S. patent application.

**Amendments to the Claims** are reflected in the listing of claims that begins on page 2 of this paper.

**Remarks** begin on page 4 of this paper.

Cabot Microelectronics Corporation  
870 North Commons Drive  
Aurora, IL, 60504  
Tel. (630) 375-5465